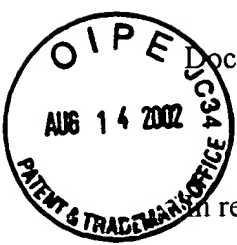


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Docket No.: 10473-784

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

H/m
#9
8/27/02

In re Application of

Dennis G. THIBEDEAU, et al.

Serial No.: 09/888,385

Group Art Unit: 2858

Filed: June 26, 2001

Examiner: Unknown

For: ALTERNATOR TESTING METHOD AND SYSTEM USING RIPPLE DETECTION

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

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Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Supplemental Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

In accordance with 37 CFR 1.17(p), please charge the fee of \$180.00 to Deposit Account No. 500417.

007/15/2002 EXTBDEF1 00000051 500417 09888385
01 FD:126 180.00 CH

Each non-English language reference was cited in an International Search Report and its relevance discussed therein. A copy of the International Search Report is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

A handwritten signature in black ink that reads "Wei-Chen Chen". The signature is written in a cursive, flowing style.

Wei-Chen Chen

Admitted under 37 CFR 10.9 (b)

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Washington, DC 20005-3096
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Date: August 14, 2002



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Expires: June 24, 2003

Harry I. Moatz
Director of Enrollment and Discipline